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U.S. DEPARTMENT OF COMMERCE Patent and Trademark Office

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT No. : 6,899,817

DATED : May 31, 2005

INVENTOR(S): Volker BECKER et al

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the face of the patent, # (57) Abstract, line 1, change "A method and a suitable device for carrying out this method" to "A method and a device is for-

On the face of the patent, # (57) Abstract, line 2, delete "is proposed, for"

On the face of the patent, # (57) Abstract, line 2, change "a substrate (18), 1/19/06 especially a silicon" to --a substrate, e.g., a silicon--

On the face of the patent, # (57) Abstract, line 3, change "plasma (14)." to --plasma.--

On the face of the patent, # (57) Abstract, line 6, delete "(14)"

On the face of the patent, # (57) Abstract, line 6, change "a reactor (15)." to --a reactor.--

On the face of the patent, # (57) Abstract, line 10, change "in particular" to --such as--

On the face of the patent, # (57) Abstract, line 10, delete "(21)"

On the face of the patent, # (57) Abstract, line 12, delete "(10)"

On the face of the patent, # (57) Abstract, line 12, change "ICP source (13). For this" to --ICP source.--

On the face of the patent, # (57) Abstract, line 13, change "the magnetic field" to --The magnetic field--

On the face of the patent, # (57) Abstract, line 15, delete "(10)"

On the face of the patent, # (57) Abstract, line 16, change "plasma (14)." to --plasma.--

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